

AUG 30 2004

FORM PTO-1449/A and B (Modified)

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

APPLICATION NO.: 09/808,745

ATTY. DOCKET NO.: H0498.70135US00

FILING DATE: March 15, 2001

CONFIRMATION NO.: 4346

APPLICANT: Emanuele Ostuni et al.

GROUP ART UNIT: 1651

EXAMINER: Deborah K. Ware

Sheet 1 of 2

U.S. PATENT DOCUMENTS

Examiner's Initials	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication or of issue of Cited Document MM-DD-YYYY
		Number	Kind Code		

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OTHER ART — NON PATENT LITERATURE DOCUMENTS

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EXAMINE R

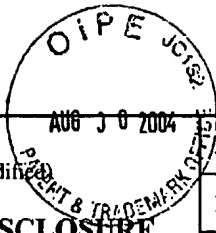
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11-10-04

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				GROUP ART UNIT: 1651		EXAMINER: Deborah K. Ware	
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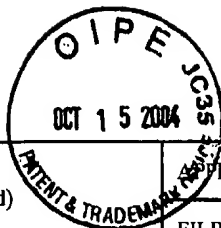
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EXAMINE R	<i>Deborah K. Ware</i>	DATE CONSIDERED	11-10-04
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APPLICANT: Emanuele Ostuni

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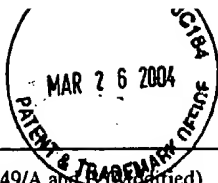
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[NOTE - The Office hereby waives the requirement under 37 CFR 1.98 (a)(2)(i) for submitting a copy of each cited U.S. patent and each U.S. patent application publication for all U.S. national patent applications filed after June 30, 2003 and for all international applications that have entered the national stage under 35 USC 371 after June 30, 2003. See 37 CFR 1.491(b). For all patent applications filed on or before June 30, 2003, copies of cited U.S. patents and patent application publications are still required unless an IDS is filed. Copies of all other patent(s), publication(s), or other information listed must still be provided, even if it was previously submitted to, or cited by, the U.S. Patent Office in an earlier application, unless the earlier application is identified by the IDS and is relied upon for an earlier filing date under 35 U.S.C. §120, and the copy was provided in the earlier application.]



FORM PTO-1449/A and (B)(1) (Rev. 11-19-97)

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Skw	29	JACKMAN, R.J., WILBUR, J.L., AND WHITESIDES, G.M., "Fabrication of Submicrometer Features on Curved Substrates by Microcontact Printing", Science, Vol. 269, August 4, 1995	
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